

Electronic Acknowledgement Receipt

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International Application Number:	
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Title of Invention:	Low temperature deposition of silicon oxides and oxynitrides
First Named Inventor/Applicant Name:	Yoshihide Senzaki
Customer Number:	32940
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	67538-5172_IDS_Ref.pdf	234341 <small>25 1b1b4061693ea0ff2184a5256592c1091eece9</small>	no	5

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2	Foreign Reference	67538-5172_EP_Ref.pdf	634278 3b90aed1c0879b6c22113ba7ee13c55657a05c	no	10
Warnings:					
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3	Foreign Reference	67538-5172_KR_Ref.pdf	612568 ca1a52be7827d9e1dca4578015c1c88ff923cd2	no	8
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4	Foreign Reference	67538-5172_WO_Ref.pdf	1604029 10d3d5455721964805d27181bfbce4fc2924544b	no	50
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5	NPL Documents	67538-5172_GORDON_Ref.pdf	246935 dc144a0edfa915085214d3ca1f159720517123d79	no	2
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6	NPL Documents	67538-5172_Hausmann_Ref.pdf	940420 f4f620c4f6a19f8ba93581b5d23bc8f2005630191	no	11
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7	NPL Documents	067538-5172_KUKLI_Ref.pdf	434802 94b1d85c75c1a797c76360bdc0dfc088dc0eaa02	no	6
Warnings:					
Information:					
8	NPL Documents	67538-5172_PCT25739_Ref.pdf	231077 a1e9eb0793489565049c0596127815021ca080a8	no	4
Warnings:					
Information:					
9	NPL Documents	67538-5172_PCT25738_Ref.pdf	259214 7a21eb3952eb4d8f91c7c3c0bc03ec949d19a1a	no	4
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10	NPL Documents	67538-5172_PCT26083_Ref.pdf	328187 <small>ee0c18db6ca0c060bcb379d68e874a353a7a5c4e</small>	no	5
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